

3749

PATENT

DK-US045032

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Norio MAEDA et al.

Serial No.: 09/889,484

Filed: December 20, 2001

For: METHOD AND DEVICE FOR DRYING  
SUBSTRATE

:  
:  
:  
:  
:  
:  
:  
:  
:  
:  
:

Patent Art Unit: 3749

Examiner: Pamela Anne Wilson

**PETITION FOR ACCEPTANCE OF  
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner of Patents  
Washington, DC 20231

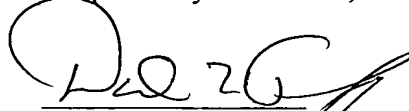
Sir:

In accordance with MPEP 609 and 37 C.F.R. §§ 1.56, 1.97 and 1.98, applicants bring the attached references to the Examiner's attention and request that they be considered and made of record in this application. Also attached are a completed PTO-149 form and a copy of August 30, 2002 European Search Report. The undersigned believes that this Information Disclosure Statement (IDS) is being filed after the mailing of a first Office Action on the merits, but before the mailing of a final action, a notice of allowance, or an action that otherwise closes prosecution in the application.

Applicants hereby petition that this Information Disclosure Statement be entered into the above-identified application and considered by the Examiner in charge of the above-identified application. Enclosed is a check for \$180.00 to cover the petition fee of 37 CFR § 1.17(p). ***No other fees are believed to be due for this Information Disclosure Statement.*** However, the Commissioner is authorized to charge any fees associated with this communication or credit any overpayment to Deposit Account No. 50-1836. A duplicate copy of this Statement is enclosed for that purpose.

If there are any questions regarding this Petition and/or this Information Disclosure Statement, please contact the undersigned.

Respectfully submitted,

  
David L. Tarnoff  
Reg. No. 32,383

SHINJYU GLOBAL IP COUNSELORS, LLP  
1233 Twentieth Street, NW, Suite 700  
Washington, D.C. 20036  
(202)-293-0444  
Dated: 4-13-04

G:\04-APR04-MSM\DK-US045032 IDS.doc

Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number.

Substitute for form 1449A/PTO

# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

*(use as many sheets as necessary)*

Sheet	1	of	1
-------	---	----	---

**Complete if Known**

Application Number	09/889,484
Filing Date	December 20, 2001
First Named Inventor	Norio MAEDA
Group Art Unit	3749
Examiner Name	Pamela Anne Wilson
Attorney Docket Number	DK-US045032

## U.S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

Examiner  
Signature

Date  
Considered

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>1</sup> Applicant's unique citation designation number (optional). <sup>2</sup> See Kinds Codes of USPTO Patent Documents at [www.uspto.gov](http://www.uspto.gov) or MPEP 901.04.

<sup>3</sup> Applicant's unique creation designation number (optional). See Rules Governing the Patent Documents at [www.uspto.gov](http://www.uspto.gov) or WIPO Standard ST.3. <sup>4</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>5</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>6</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>7</sup> Applicant is to place a check mark here if English language Translation is attached.

**Burden Hour Statement:** This form is estimated to take 2.0 hours to complete. Time will vary depending upon the needs of the individual case. Any comments on the amount of time you are required to complete this form should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, Washington, DC 20231. **DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO:** Assistant Commissioner for Patents, Washington, DC 20231.